

JCS32 U.S. PTO
10/038990
01/04/02

PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

912

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10038990	01/04/2002	148	115	2812	

****APPLICANTS:** Joo Seung-Ki; Lee Seok-Woon;

****CONTINUING DATA VERIFIED:** No
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**** FOREIGN APPLICATIONS VERIFIED:**
REPUBLIC OF KOREA 2001-385 01/04/2001 Yes
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PG-PUB ☐ DO NOT PUBLISH ☐ RESCIND ☐

Foreign priority claimed ☒ yes ☐ no
35 USC 119 condition met ☒ yes ☐ no
Verified and Acknowledged Examiners's initials

ATTORNEY DOCKET NO
069457.0106

TITLE : Method and apparatus for fabricating a semiconductor device

U.S. DEPT. OF COMM./PAT & TM-PTO-436 (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claim for O.G.
Assistant Examiner		DRAWING	
Amount Due		Sheets Drwg.	Figs.Drwg.
Date Paid		Print Fig.	
<input type="checkbox"/> TERMINAL DISCLAIMER		Application Examiner	
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